

Notice of References Cited	Application/Control No.	Applicant(s)/Patent Under Reexamination	
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	Examiner	Art Unit	
	Scott B. Geyer	2829	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,650,639	07-1997	Schrantz et al.	257/77
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)	
	U	Liu et al., "DIAMOND CHEMICAL VAPOR DEPOSITION: Nucleation and Early Growth Stages", 1995, pages 1-7.	
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*A copy of this reference is not being furnished with this Office action (See MPEP § 707.05(a))
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